Docket No.: 67160-014 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Tetsuya MATSUURA, et al.

Serial No.:

Group Art Unit:

Filed: July 29, 2003

Examiner:

For:

SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURE THEREOF

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of JP 11-112121 is discussed in the present specification.

Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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CUSTOMER NUMBER 20277

Date: July 29, 2003

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					APPLICANT Tetsuya MATSUURA, et al.				
(PTO-1449)					FILING DATE July 29, 2003	GROUP			
				U.S. PATENT	F DOCUMENTS				
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (# known)		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
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EXAMINER'S INITIALS	CITE NO.	Fo	reign Patent Document ntry Codes -Number 4 -Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Line Where Relevant Figures Appear			
								Yes	No
	1	t	JP 11-112121	04/23/1999	HATSUPOUYA		~ ~	abstract	
		1	JP 2002-57275	02/22/2002	KARIYA			abstract	
			JP 2002-57276	02/22/2002	KARIYA			abstract	
			JP 2002-110901	04/12/2002	KAMEI, et al.			abstract	
			JP 2001-94045	04/06/2001	KOMIYAMA			abstract	
			JP 10-163420	06/19/1998	SAKAGUCHI, et al.			abstract	
	DX				r, Title, Date, Pertinent Pages, E				
EXAMINER'S INITIALS	CITE NO.	journ	de name of the author (in al, serial, symposium, cat shed.	CAPITAL LETTERS alog, etc.), date, pag), title of the article (when approje(s), volume-issue number(s), p	oriate), title of th ublisher, city an	e item (bo d/or count	ok, magazine ry where	,
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.